

AUG 27 2007

Docket No. 740756-2100

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Confirmation No.: 6768
Hongyong Zhang)	
Serial No. 09/633,869)	Examiner: Alexander G. Ghyka
Filed: August 7, 2000)	Group Art Unit: 2812
For: METHOD FOR LASER- PROCESSING SEMICONDUCTOR DEVICE)	Date: August 27, 2007

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Non-Final Office Action mailed April 27, 2007, please amend the above-captioned application, as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks follow the amendment section of this paper.

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